

10/587039

IAP6 Rec'd PCT/PTO 24 JUL 2006

Attorney Docket No. 061063-0356139
Client Reference: OSP-19398

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: MASATAKA HOURAI, WATARU SUGIMURA and TOSHIAKI ONO

Application No.: Confirmation No:
Filed: July 24, 2006 Group No.:
For: SILICON WAFER, METHOD FOR MANUFACTURING THE SAME AND METHOD FOR
GROWING SILICON SINGLE CRYSTALS Examiner UNASSIGNED

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

APPLICATION DATA SHEET
37 C.F.R. § 1.76

BIBLIOGRAPHIC DATA

1. Applicant information

First applicant: MASATAKA HOURAI
Citizenship: JAPAN
Residence: Saga-shi, Japan

Second applicant: WATARU SUGIMURA
Citizenship: JAPAN
Residence: Saga-shi, Japan

Third applicant: TOSHIAKI ONO
Citizenship: JAPAN
Residence: Saga-shi, Japan

2. Correspondence information

Correspondence for this application should be addressed as follows:

Customer No.: 00909

3. Application information

Title of Invention: SILICON WAFER, METHOD FOR MANUFACTURING THE SAME AND
METHOD FOR GROWING SILICON SINGLE CRYSTALS

Docket number assigned to this application: 061063-0356139

Suggested Classification: Class:

Subclass:

Technology Center to which subject matter is assigned:

Total number of drawing sheets: 12

Type of application: Utility

Application is to be published. Suggested drawing figure for publication: 1

Secrecy order under § 5.2:

This application does not disclose subject matter of an application which is under a secrecy order pursuant to § 5.2.

4. Representative information

The following have a power of attorney or authorization of agent in this application:

Customer No.: 00909

5. Domestic Priority information

Domestic priority for this application is claimed as follows:

35 U.S.C. § 365(c):

Application No.: PCT/JP2005/015346

Filed: August 24, 2005

Status: Pending

Relationship: Parent

6. Foreign priority information

Foreign priority is claimed for this application as follows:

Country: JP

Application No.: 2004-246017

Filing Date: August 25, 2004

Status: Pending

Country: JP

Application No.: 2005-163152

Filing Date: June 2, 2005

Status: Pending

Country: JP

Application No.: 2005-239529

Filing Date: August 22, 2005

Status: Pending

7. Assignee information

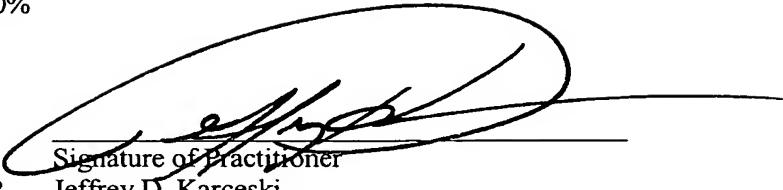
The assignee(s) of this application is/are:

SUMCO CORPORATION
2-1, Shibaura 1-chome, Minato-ku
Tokyo,
Japan

Extent of interest of assignee in application: 100%

Date: July 24, 2006

PILLSBURY WINTHROP SHAW PITTMAN LLP
P.O. Box 10500
McLean, VA 22102
Customer No. 00909



Signature of Practitioner
Jeffrey D. Karceski
Registration No. 35914
(202) 663.8403